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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 1762  
Examiner: To be assigned

In Re PATENT APPLICATION Of:

Applicant(s): Hiroomi TSUTAE )

Serial No.: 10/657,207 )

Filed: September 9, 2003 )

For: Process of cleaning a semiconductor  
manufacturing system and method of  
manufacturing a semiconductor device )

Attorney Ref: FUJI 136 )

**STATUS REQUEST**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Please let us know the status of the above-identified application and when an Action may be expected. If the response to this status request is made by telephone, please as for Tonya Harris (Docket Clerk) at extension 518.

Respectfully submitted,

*Steven M. Rabin*

January 30, 2006  
Date

SMR:ss

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